



ZFK

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : In-De Ou et al. Confirmation No: 4280  
Appl. No. : 10/627,609  
Filed : July 28, 2003  
Title : CIRCUIT SUBSTRATE AND FABRICATION METHOD  
THEREOF  
  
TC/A.U. : 2818  
Examiner : Phuc T. Dang  
  
Docket No.: : OUIIN3001/REF  
Customer No: : 23364

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is in response to the Official Action of May 25, 2005, in connection with the above-identified application. This response is timely filed.

Please amend the application as follows:

Amendments to the claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.